SEP 0 8 2004

Practitioner's Docket No. MI22-2296

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Garo J. Derderian et al.

Application No.: 10/671,922 Filed: 09/24/03

Group No.: 1762

Examiner: Unassigned

For: Atomic Layer Deposition Methods, and Methods of Forming Materials Over Semiconductor

Commissioner for Patents Washington, D.C. 20231

CERTIFICATION OF FACSIMILE TRANSMISSION

I hereby certify that the following papers are being facsimile transmitted to the Patent and Trademark Office at (703) 872-9306 on the date shown below:

Facsimile Transmittal Supplemental Information Disclosure Statement PTO-Form 1449 and cited foreign reference and articles

Robin Saldivia

Signature

Total Pages 102

PRIOR TO THE FIRST OFFICE ACTION, THEREFORE NO FEE IS REQUIRED.

BEST AVAILABLE COPY

SEP-08-2004 16:28 WELLS ST JOHN PS 5098383424 P.02

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No.	10/671,922
Inventor	September 24, 2003
Group Art Unit	Micron Technology, Inc.
Examiner	1762
Attorney's Docket No.	Unassigned
Customer No.	1762 Unassigned MI22-2296
	Ml22-2296

Title: Atomic Layer Deposition Methods, and Methods of Forming Materials Over Semiconductor Substrates

INFORMATION DISCLOSURE STATEMENT

References - - See attached Form PTO-1449

In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the United States patents and other references listed on the attached Form PTO-1449. No admission is made regarding whether all the submitted references are prior art.

The citations listed may be material to the examination of the subject application and are therefore submitted in compliance with the duty of disclosure defined in 37 CFR '1.56. Copies of the cited art are included with the exception of U. S. patents and published U. S. applications (1276 Off. Gaz. Pat. Off., 05 August 2003). No admission is made regarding whether all the submitted references are prior art. The Examiner is requested to make these citations of official record in this application.

This Supplemental Information Disclosure Statement is being filed before the mailing of a first Office Action, therefore, no fee is believed to be required. However, in the event that a fee is required for filing this Supplemental Information Disclosure Statement, please charge the fee specified under 37 C.F.R. §1.17(p) to Deposit Account No. 23-0925. Please credit Deposit Account No. 23-0925 with any overpayment of the above fee.

Citation of these references is respectfully requested.

Date: 9/8/04

Respectfully submitted,

David G. Latwesen, Ph.D.

Reg. No. 38,533 Wells St. John P.S.

601 W. First Avenue, Suite 1300 Spokane, WA 99201-3828

(509) 624-4276

Sheet I of I

P.04

Form PTO-144	9			ATTY. DOCKET MI22-2296		SERIAL NO.						
		LI	ST OF ART CITED	AFFLICANT Goro J. Derderlen p. ul.								
	_			,		FILING DATE			GROUP			
					U.S. PATENT DOCUMENTS	September 24, 200	13	1762				
"Exuminer Initial			cument mbcr	Duce	Duze Name		Class	Subclass	Subclass Filing D			
		6.5	66.262 B1	05/20/03	Rissman et nj.		 	 	If Appropriate			
	AB 6,022,595		02/06/00			 	ļ					
	<u> </u>				FOREIGN PATENT DOCUMENTS			<u> </u>	<u> </u>			
			zumeni aber	Date	Country			Subcluse	Transletion			
	AC WO 02/27063 A2		02/2706) A2	04/04/02	10105 BCL			<u> </u>	Yes	No		
					ENCES (including Author, Title, Dare, Pa	rtineat Pages, Etc.)		<u> </u>	<u></u>	<u> </u>		
	AD				n. www.webelements.com/webelements.		01-7783417.hum					
			3 pages.									
	АE		Web page - Volland,	Dr. Walt, Onli	ne Introductory Chemistry - Pelar Mok	cular Compounds						
			www.scidiv.boc.ou.	rds://vv/57/0005-0	(P)-poler-molecules.hum) 4 pages.							
	ΑГ	AP Luhunn et ol., "A Reversibly Switching Surface," Science - Vol 299, Junuary 17, 2003, pages 371-374.										
									·			
!	AG		Sun et al., "Shape-Controlled Symbesis of gold and Silver Nanopanicles," Science - Vol 298, Decomber 13, 2002, pages 2176-2179.									
- 1	IIA		Hausmann et al., "Rapid Vupor Deposition of Highly Conformal Silien Nanolaminutes," Science - Vol. 298, October \$1, 2002, pages 402-406.									
										-		
ľ	~		Malynych et al., "Poly(Viny) Pyridine) as a Universal Surface Modifier for Immobilization of Nonoparades,"									
			American Chemical									
	AJ Feng et al., "Study of the photophysical properties of composite film assembled of perphysin and TiQ , nanoparaletes,"											
		-	Elievier Science S.A									
	^K	\dashv	Arigo et al., Ultrathin film				and molybdenur	n oxide) propa	red by alternar	•		
	_	_	layer-by-layer sesons	ly with organic	e polyions." Elzevier Science B.V. @19	99.			_			
	٨.	_										
Address:		\perp	- ,									
MINER 					DATE CONSIDERED							
AMINER: Init	ial if refe	reace cu	insidered whether as	alaust to to	unformance with MPEP 609; Draw line							

This Page is Inserted by IFW Indexing and Scanning Operations and is not part of the Official Record

BEST AVAILABLE IMAGES

Defective images within this document are accurate representations of the original documents submitted by the applicant.

Defects in the images include but are not limited to the items checked:

BLACK BORDERS

IMAGE CUT OFF AT TOP, BOTTOM OR SIDES

FADED TEXT OR DRAWING

BLURRED OR ILLEGIBLE TEXT OR DRAWING

SKEWED/SLANTED IMAGES

COLOR OR BLACK AND WHITE PHOTOGRAPHS

GRAY SCALE DOCUMENTS

LINES OR MARKS ON ORIGINAL DOCUMENT

REFERENCE(S) OR EXHIBIT(S) SUBMITTED ARE POOR QUALITY

IMAGES ARE BEST AVAILABLE COPY.

☐ OTHER:

As rescanning these documents will not correct the image problems checked, please do not report these problems to the IFW Image Problem Mailbox.